



Form PTO 1449 (Modified)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY DOCKET NO.		SERIAL NO.		
				243203US2RD		10/670,279		
				APPLICANT Hideki SATAKE				
LIST OF REFERENCES CITED BY APPLICANT				FILING DATE		GROUP		
				September 26, 2003		2814		
U.S. PATENT DOCUMENTS								
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE	
LP ↓	AA	6,225,151	5/1/2001	GARDNER et al.				
	AB	5,827,774	10/27/1998	KITAJIMA				
	AC	6,300,664	10/9/2001	KUROI et al.				
	AD	6,288,433	9/11/2001	AKRAM et al.				
	AE	5,885,884	3/23/1999	JAN et al.				
	AF	6,242,356	6/5/2001	JANG et al.				
	AG							
	AH							
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	AK							
	AL							
	AM							
	AN							
	FOREIGN PATENT DOCUMENTS							
			DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION		
LP ↓	AO	EP 0 350 845	1/17/1990	EUROPE	YES	NO		
	AP	EP 0 706 204	4/10/1996	EUROPE	X			
	AQ							
	AR							
	AS							
	AT							
	AU							
	AV							
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)								
LP LP	AW	YASUOKA, A. et al., "THE EFFECTS ON METAL OXIDE SEMICONDUCTOR FIELD EFFECT TRANSISTOR PROPERTIES OF NITROGEN IMPLANTATION INTO P+ POLYSILICON GATE", Japanese Journal of Applied Physics, Vol. 36, No. 2, February 1997, pgs. 617-622, XP-000735532						
	AX	HSING-HUANG TSENG, "FLUORINE DIFFUSION ON A POLYSILICON GRAIN BOUNDARY NETWORK IN RELATION TO BORON PENETRATION FROM P+ GATES", IEEE Electron Device Letters, Vol. 13, No. 1, January 1992, pgs. 14-16, XP 000244049						
	AY							
	AZ					<input type="checkbox"/> Additional References sheet(s) attached		
Examiner				Date Considered				
LONG PHAM				1/11/06				
*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								